

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Prior Application: R. TSUCHIYA et al  
Serial No. 10/372,329  
Filed: February 25, 2003

Group Art Unit: 2814  
Examiner: N.V. Ngo  
For: MIS SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREOF

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
Mail Stop Patent Application  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above application  
as follows.